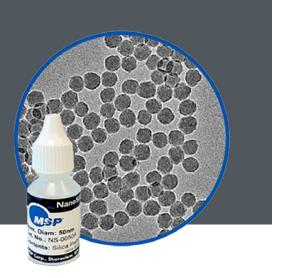


NanoSilica™ Size Standards



Concentrated aqueous suspensions of SiO₂ particles with highly uniform size distributions

NanoSilica[™] Size Standards from MSP, a Division of TSI®, are ideally suited for producing high-quality calibration standards for the next generation of wafer and photomask inspection systems. They are available in nominal sizes ranging from 15 to 200 nm.

Applications

- Wafer and reticle (photomask) inspection tool calibration
- Inspection tool development and qualification
- Incoming bare wafer inspection/qualification
- Blanket film monitoring
- Incoming reticle (photomask) inspection/qualification
- Production reticle (photomask) monitoring
- Process tool qualification and monitoring
- Particle counter calibration

Benefits

- Easily discern modal (peak) diameter
- Avoid discrepancies due to differences between mean and peak diameter values
- Prepare diluted suspensions suitable for aerosol generation devices with relatively high or low efficiencies
- Create long-lasting calibration standards for state-of-the-art inspection tools
- Consume less material; save money
- Comes with a Certificate of Calibration and Traceability and a Safety Data Sheet (SDS) with handling and disposal instructions

Features

- Extremely uniform size distribution
 Manufactured with a patented SiO₂ synthesis process,
 Our NanoSilica M Size Standards have size distributions
- our NanoSilica™ Size Standards have size distributions narrower than commercially available PSL spheres.
- Peak diameter measured with SI traceability
 Allows yield-enhancement and metrology groups to establish traceability of their inspection and defect review methods in accordance with ISO 9000 standards and SEMI guidelines.
- Stable when subjected to intense DUV radiation MSP's SiO₂ particles will not degrade when exposed to DUV radiation, unlike PSL spheres, which can decrease in size.
- Easy to use
 - NanoSilica particle suspensions are available in droppertip bottles for convenience when mixing suspensions with appropriate number concentrations for your applications.
- High particle concentration
 Some applications require high number concentrations.
 MSP's particle concentrations are one of the highest in the industry.

Nanosilica™ Size Standards



Standard Offerings

Other sizes may be available upon request. Please contact MSP™ for more information.

Model (Starting with 2260-02-)	Catalog Number	Nominal Particle Diameter [nm]	Certified ¹ Peak Diameter [nm]	Approx. Size Dist. Width, RFWHM ²
1044	NS-0015A	15	14-16	13%
1046	NS-0018A	18	17-19	12%
1047	NS-0020A	20	19-21	11%
1073	NS-0022A	22	21-23	11%
1048	NS-0024A	24	23-25	10%
1074	NS-0026A	26	25-27	9%
1075	NS-0027A	27	26-28	9%
1049	NS-0030A	30	29-31	8%
1079	NS-0032A	32	31-33	7%
1062	NS-0035A	35	34-36	7%
1076	NS-0037A	37	36-38	6%
1051	NS-0040A	40	39-41	6%
1063	NS-0045A	45	44-46	5%
1052	NS-0050A	50	49-51	5%
1077	NS-0055A	55	53-57	5%
1053	NS-0060A	60	58-62	4%
1067	NS-0064A	64	62-66	4%
1054	NS-0070A	70	68-72	4%
1068	NS-0074A	74	72-76	4%
1055	NS-0080A	80	78-82	4%
1069	NS-0084A	84	82-86	4%
1057	NS-0090A	90	88-92	4%
1070	NS-0094A	94	92-96	4%
1058	NS-0100A	100	98-102	4%
1071	NS-0104A	104	102-106	4%
1059	NS-0125A	125	120-130	4%
1060	NS-0150A	150	145-155	4%
1061	NS-0200A	200	190-210	4%

¹ Certified diameter for a given catalog number will be provided in the stated range.

The MSP logo is a trademark of MSP Corporation. TSI and the TSI logo are registered trademarks of TSI Incorporated.

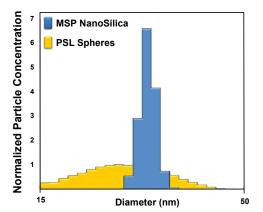


MSP - Visit our website www.tsi.com/msp for more information.

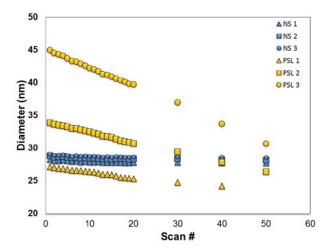
5910 Rice Creek Parkway, Suite 300 Shoreview, Minnesota 55126, U.S.A. Tel: 651.287.8100

Specifications

Particle Composition	Amorphous SiO ₂	
Particle Density	1.9 g/cm ³	
Index of Refraction	1.41 @ 633nm	
Volume	5 mL	
Concentration	10 ¹³ to 10 ¹⁵ particles per mL	
Expiration Date	≥ 24 months	
Additives	Ethanol (5-20% by mass) Organic stabilizer (<0.1% by mass)	
Storage & Handling	Store at room temperature (See Certificate of Calibration and Traceability for more details.)	



Comparison of size distributions of a commercially available PSL size standard (30 nm) and MSP's NanoSilica™ (30 nm). Suspensions of particles were aerosolized with aerosol electrospray (TSI® Model 3480). Size distributions were measured by particle mobility spectrometry. Particle suspensions were diluted in equal volume ratios.



Comparison of NanoSilica and PSL stability under DUV laser illumination: particle sizes measured with repeated SSIS scans of NanoSilica particles (30 nm nominal; blue symbols) and PSL spheres (30, 40, 50 nm nominal; yellow symbols) deposited on a silicon wafer.

² Relative FWHM (full-width at half-maximum); FWHM divided by modal diameter.